

Notice of References Cited	Application/Control No. 10/051,211	Applicant(s)/Patent Under Reexamination CADIEU, FRED J.	
	Examiner Richard Bueker	Art Unit 1763	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-6,319,369	11-2001	Flynn et al.	204/192.38
	C	US-6,533,908	03-2003	Meyer et al.	204/192.37
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	U	Jordan, Pulsed Laser Deposition of Particulate-Free Thin Films Using a Curved magnetic Filter, Applied Surface Science 109-110, (1997), pp. 403-407.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.